



**ELECTRONIC COPY**

LG733539830  
Report verification at igi.org



September 11, 2025

IGI Report Number **LG733539830**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **KITE STEP CUT**

Measurements **15.78 X 9.32 X 4.36 MM**

**GRADING RESULTS**

Carat Weight **3.01 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

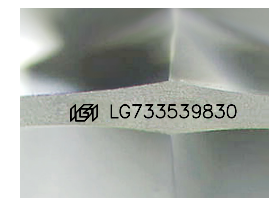
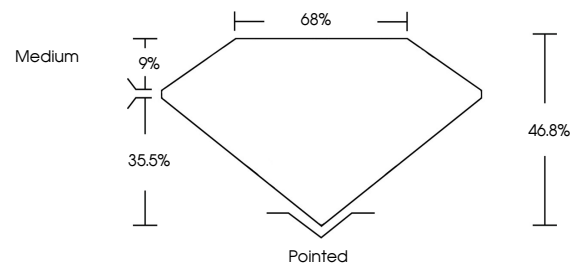
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG733539830**

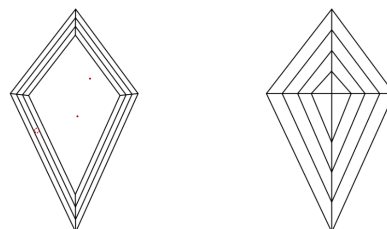
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

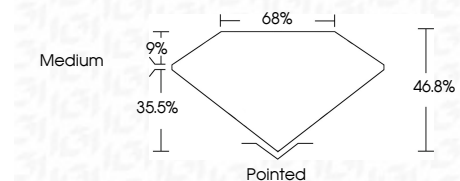
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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KITE STEP CUT

3.01 CARATS  
E

15.78 X 9.32 X 4.36 MM

Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle

VVS 2  
E  
VVS 2  
35.5%  
68%  
Medium

Pointed  
EXCELLENT  
EXCELLENT  
NONE  
NONE  
IGI LG733539830

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

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